

Gas Purifier for CI/MS Applications

- 1/8" compression fittings
- 1000 psig pressure rating
- Compatible with most CI gases
- Welded stainless steel body



Description

The use of Chemical Ionization Mass Spectroscopy has increased in recent years, with instrumentation to perform this sensitive analytical technique now available commercially. In response to this growth, VICI Metronics has developed a gas purifier designed specifically for the unique demands of chemical ionization.

Several types of contaminants are detrimental to CI performance – notably moisture, heavy hydrocarbons, halocarbons, and oxygen. A Metronics CI purifier module placed in line with the gas delivery system removes these contaminants, reducing levels from many parts per million to levels that are below the lower limit of analytical detection, and retains them for the operating life of the purifier. (Recommended replacement is after three bottles of gas, or if detector baseline drift and noise become apparent.)

Successive Beds for Peak Performance

A very high capacity has been engineered into the gas purifier by using several different materials for gross contaminant removal and additional materials for the removal of trace amounts of the contaminants. Three separate adsorption chemistries are incorporated into the operating design of the gas purifier to insure the optimal capacity and efficiency. This successive bad format insures high capacity as well as a very high efficiency for the removal of contaminants that can be present in even high purity methane.

Our successive bed format achieves the highest purity gas commercially available

Two very high capacity hydrocarbon and moisture sorbents at the inlet for effective contaminant removal

Unique proprietary broad spectrum sorbent material for multiple contaminant removal

Multiple bed format to allow several step reduction in contaminants

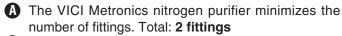
Removal of H₂O, O₂, halocarbons, hydrocarbons, CO, CO₂, H₂, and sulfur containing compounds with a single purifier

Very high efficiency sorbents at the outlet for trace contaminant removal



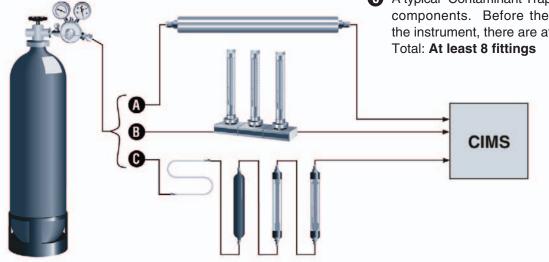
Fittings: the Fewer the Better

Every connection in your gas delivery system has the potential for leaks; the more fittings you have, the greater the potential. In the illustration below, several gas purification options are depicted:



The "Manifold System" has two compression fittings for the system and one organic O-ring seal for each cartridge. Total: At least 5 fittings

G A typical "Contaminant Trap" configuration has several components. Before the gas supply even enters the instrument, there are at least 4 modules.



Specifications

Length	Pressure drop, 862 kPa (125 psi) inlet,
Diameter	at a flow of 0 to 500 ml/min<0.20 psi
Maximum inlet pressure 6895 kPa (1000 psi)	End fittings
Maximum recommended flow 500 ml/min	Shipping weight800 g (1.76 lb)

Selection Guide and Ordering Information

Product Description Produ	Product no.	uct no. Fittina	PPB at outlet, based on 50 PPM nominal inlet concentration level		
	Flounct no.	Fitting	02	H ₂ 0	Sulfur compounds
CI purifier	P-500-1	1/8"	<1	<1	<1



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